

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	276	semiconductor with (fab fabricat\$4) with (simulat\$4 model\$4)	USPAT	OR	OFF	2006/02/20 14:53
L2	6	(fair adj model) or (fair adj diffusion adj model)	USPAT	OR	OFF	2006/02/20 14:53
L3	1	("6154717").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/02/20 14:53
L4	8	"10/989011" "10/780938" "10/668621" "09/891400" "09/781421" "09/519856"	US-PGPUB; USPAT; USOCR	OR	OFF	2006/02/20 14:53
L5	1661	703/2.ccls.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/02/20 14:53
L6	162	L5 and (diffusion impurit\$3 impure)	US-PGPUB; USPAT; USOCR	OR	OFF	2006/02/20 14:53
L7	200	("pile-up" (pile adj up)) same (diffusion diffus\$4)	US-PGPUB; USPAT; USOCR	OR	OFF	2006/02/20 14:53
L8	1	10/059176	US-PGPUB	OR	OFF	2006/02/20 14:53
L9	1	"6581028".pn.	USPAT	OR	OFF	2006/02/20 14:53
L10	258	reverse adj short adj channel	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/02/20 14:53
L11	21	("5930494" "5819073" "5557710" "5684723" "6195790" "5148379" "6360190" "6242272" "6006026" "6080200" "5828586" "5889687" "6185472" "5819073" "6041424" "4584662" "6182270" "6011914" "6144932" "6360190" "6154717" "6505147" "6144929").pn.	USPAT	OR	OFF	2006/02/20 14:53
L12	13	("5103415" "5671395" "5675522" "5677846" "5774696" "5784302" "5819073" "5828586" "5889680" "5930494" "5963732" "6006026" "6011914").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/02/20 14:53

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L13	19	(US-4607530-\$ or US-6594625-\$ or US-6006026-\$ or US-6684181-\$ or US-6327555-\$ or US-6285970-\$ or US-6154718-\$ or US-6154717-\$ or US-6148276-\$ or US-6144929-\$ or US-6120548-\$ or US-6041174-\$ or US-5999719-\$ or US-6581028-\$ or US-5557710-\$ or US-6242272-\$ or US-6505147-\$ or US-5889687-\$ or US-5930494-\$).did.	USPAT	OR	OFF	2006/02/20 14:53
L14	1	L13 and (SiO)	USPAT	OR	OFF	2006/02/20 14:53
L15	9	L13 and layer	USPAT	OR	OFF	2006/02/20 14:53
L16	5	L13 and (source drain)	USPAT	OR	OFF	2006/02/20 14:53
L17	4	L16 and distance	USPAT	OR	OFF	2006/02/20 14:53
L18	1	"6080200".pn.	USPAT	OR	OFF	2006/02/20 14:53
L19	266	(impurity adj diffusion) same (source drain) same (distance length)	USPAT	OR	OFF	2006/02/20 14:53
L20	41	L19 and (simulat\$4 model\$4)	USPAT	OR	OFF	2006/02/20 14:53
L21	266	(impurity adj diffusion) same (source drain) same (distance length)	USPAT	OR	OFF	2006/02/20 14:53
L22	20	(US-4607530-\$ or US-6594625-\$ or US-6006026-\$ or US-6684181-\$ or US-6327555-\$ or US-6285970-\$ or US-6154718-\$ or US-6154717-\$ or US-6148276-\$ or US-6144929-\$ or US-6120548-\$ or US-6041174-\$ or US-5999719-\$ or US-6581028-\$ or US-5557710-\$ or US-6242272-\$ or US-6505147-\$ or US-5889687-\$ or US-5930494-\$ or US-6080200-\$). did.	USPAT	OR	OFF	2006/02/20 14:53



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- ☐ 1. **Parasitic energy barriers in SiGe HBTs**
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IEEE STD IEEE Standard

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